

Notice of References Cited	Application/Control No. 10/567,701	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner JAE Y. LEE	Art Unit 2466	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,915,325	07-2005	Lee et al.	709/202
*	B	US-6,845,100	01-2005	Rinne, Mika	370/395.43
*	C	US-2006/0268819	11-2006	Chen et al.	370/349
*	D	US-7,522,601	04-2009	Morrow, Glenn	370/392
*	E	US-2002/0181468	12-2002	Lucidarme et al.	370/395.2
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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